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| 1 | CLAIM (Listing): | | |
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| 2 | Claim1 (currently amended). A plasma reformer for dissociating water and | | |
| 3 | hydrocarbon fuel in a preheated gaseous form comprising: | | |
| 4 | a turbulent heating zone containing micro-porous articulated material with a first | | |
| 5 | impervious ceramic wall laterally bounding it; | | |
| 6 | a reaction chamber downstream from the turbulent heating zone, the reaction | | |
| 7 | chamber having emitter electrode means attached to the first impervious ceramic wall | | |
| 8 | laterally bounding it, an inner lateral wall containing collector electrode means, and an | | |
| 9 | electric circuit maintained between the emitter electrode means and the collector | | |
| 10 | electrode means; | | |
| 11 | an energy retaining zone containing micro-porous articulated material arrayed | | |
| 12 | downstream from the reaction chamber; | | |
| 13 | low thermal conductivity materials surrounding the energy retaining zone; | | |
| 14 | compression-expansion cushion mat material surrounding the low thermal | | |
| 15 | conductivity material; | | |
| 16 | an ion-neutralization filter surrounding the collector electrode means in the | | |
| 17 | reaction chamber; | | |
| 18 | a casing; and | | |
| 19 | Ingress means for introducing gaseous material in a flow into the turbulent | | |
| 20 | heating zone and egress means for removing a reformate stream from the energy | | |
| 21 | retaining zone. | | |
| 22 | Claim 2 (currently amended). A plasma reformer as set forth in Claim [[1]] 18 | | |
| 23 | wherein the emitter electrode means have a multiplicity of thin needle-like extrusions. | | |
| 24 | | | |
| 25 | Claim 3 (original). A plasma reformer as set forth in Claim 2 wherein the | | |
| 26 | needle-like extrusions have diameters between 1 nanometer and 100 micrometers. | | |
| 27 | Claim 4 (currently amended). A plasma reformer as set forth in Claim 3 wherein | | |
| 28 | the emitter and collector electrode means are a metal selected from [[a]] the group | | |

consisting of tungsten, zirconium, titanium, molybdenum, and alloys thereof.

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| 1 | Claim 5 (canceled). A plasma reformer as set forth in Claim 4 further | | |
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| 2 | comprising an ion neutralizing filter surrounding the collector electrode in the reaction | | |
| 3 | chamber. | | |
| 4 | Claim 6. (currently amended) A plasma reformer as set forth in Claim [[5]] 4 | | |
| 5 | further comprising a second ceramic wall laterally surrounding the energy retaining zone | | |
| 6 | and inside of the low thermal conductivity material. | | |
| 7 | Claim 7. (currently amended) A plasma reformer as set forth in Claim 6 wherein | | |
| 8 | the material in the turbulent heating zone and the energy retaining zone have micro- | | |
| 9 | porous structure layers selected from [[a]] the group consisting of alumina, silica, mullite, | | |
| 10 | titanate, spinel, zirconia, or some combination thereof. | | |
| 11 | Claim 8. (original) A plasma reformer as set forth in Claim 7 wherein the low | | |
| 12 | conductivity materials are vacuum form fibers arrayed interior to fiber blankets, the | | |
| 13 | vacuum form fibers having a greater density and a higher percentage of higher melting | | |
| 14 | point material than the fiber blankets. | | |
| 15 | Claim 9. (currently amended) A plasma reformer as set forth in Claim 8 wherein | | |
| 16 | the compression-expansion cushion mat material is low thermal conductive material | | |
| 17 | having a great capacity of absorbing thermal compression-expansion, shocks and | | |
| 18 | vibrations and having the ability of sealing and protecting reformer material. | | |
| 19 | Claim 10. (currently amended) A plasma reformer as set forth in Claim [[5]] $\underline{1}$ | | |
| 20 | wherein the ion neutralizing ion-neutralization filter material is a semiconductor. | | |
| 21 | Claim 11. (currently amended) A plasma reformer as set forth in Claim [[5]] $\underline{1}$ | | |
| 22 | wherein the ion neutralizing ion-neutralization filter material is a ceramic alloy. | | |
| 23 | Claim 12. (currently amended) A plasma reformer as set forth in Claim 1 | | |
| 24 | wherein each there are plural electric circuits circuit is connected to a different | | |
| 25 | electricity source. | | |
| 26 | Claim 13. (currently amended) A plasma reformer as set forth in Claim 1 | | |
| 27 | wherein the ingress means for introducing gaseous material in a flow into the turbulent | | |

heating zone and the egress means for removing a reformate stream from the energy

| 1 | retaining zone are double-walled tubes have an inner wall of a ceramic material and an |
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| 2 | outer wall of stainless steel. |
| 3 | Claim 14. (withdrawn) A process for reforming a preheated gaseous mixture of |
| 4 | H ₂ O and hydrocarbon fuels to produce hydrogen comprising: |
| 5 | further heating and mixing the mixture in a turbulent heating zone; |
| 6 | dissociating the H ₂ O through ionizing and dissociating the hydrocarbon fuel through |
| 7 | ionization and heat in a reaction chamber having emitter electrodes means in an outer wall, |
| 8 | central collector electrode means, electric circuits maintained between the emitter electrode |
| 9 | means and the collector electrode means causing copious numbers of high energy electron to |
| 10 | be emitted from the emitter electrode to interact with the hydrocarbon fuel thereby |
| 11 | dissociating the hydrocarbon fuel and forming low energy electrons that dissociate H2O; and |
| 12 | further dissociating products leaving the reaction chamber in an energy retaining |
| 13 | zone. |
| 14 | Claim 15. (withdrawn) A process as set forth in Claim 14 wherein the emitter |
| 15 | electrodes have a multiplicity of thin needle-like extrusions. |
| 16 | Claim 16. (withdrawn) A process as set forth in Claim 15 wherein the needle-like |
| 17 | extrusions have diameters between 1 nanometer and 100 micrometers. |
| 18 | Claim 17. (withdrawn) A process as set forth in Claim 16 wherein the material in the |
| 19 | turbulent heating zone and the energy retaining zone have micro-porous structure layers |
| 20 | selected from a group consisting of alumina, silica, mullite, titanate, spinel, zirconia, or some |
| 21 | combination thereof. |
| 22 | Claim 18 (new). A plasma reformer as set forth in Claim 1 wherein the reaction |
| 23 | chamber is maintained in a temperature range of 400°C to 1900°C. |

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| 2 | | Respectfully submitted, |
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